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	CHANG, KEN K.
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6. ☐ Interview Sum Paper No./Ma 7. ☐ Examiner's An	mal Patent Application (PTO-152) mary (PTO-413), ail Date nendment/Comment atement of Reasons for Allowance
	aminer ellion A. Sanders on the cover sheet with a REMAINS) CLOSED in the ther appropriate community. This application is submitted a submitted and the attached EXAM ason(s) why the oath or described. Note the attached EXAM ason(s) why the oath or described. Patent Drawing Review (endment / Comment or in the attached EXAM ason(s) why the oath or described. Patent Drawing Review (endment / Comment or in the attached EXAM ason(s) why the oath or described. Patent Drawing Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described as a following Review (endment / Comment or in the attached EXAM ason(s) why the oath or described ason (s) why the oath or described as a following Review (endme

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REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance:

2. Applicant's comparative data in the specification at pages 13 and 14, Tables I and II indicate an unexpected increase in hot and cold tensile strengths for the binder compositions containing BHMFO, (which is a mixture of bis-hydroxymethyl furan monomers, furfuryl alcohol and di-methylolated furan, with at least 50% dimeric methylolated furan), than for binders having equivalent components with the exception of BHMFO.

3. Prior art cited on form 892 provide technological background information on furan binder resin systems. However these patented systems do not contain methylolated furan.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kriellion A. Sanders whose telephone number is 571-272-1122. The examiner can normally be reached on Monday through Thursday 6:30-7:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Vasu Jagannathan can be reached on 571-272-1119. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Kriellion A. Sanders Primary Examiner Art Unit 1714